

00684.003278.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Chidane OUCHI

Application No.: 09/986,324

Filed: November 8, 2001

For: PROJECTION EXPOSURE APPARATUS
AND DEVICE MANUFACTURING METHOD
THAT CHANGE A RESONATOR LENGTH OF A
CONTINUOUS EMISSION EXCIMER LASER (As
Amended)

)
:
) Examiner: P. B. Kim

)
:
) Group Art Unit: 2851

)
:
) Confirmation No.: 5125

)
:
) March 15, 2004
(Monday)

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

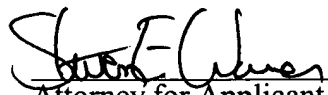
Further to the Information Disclosure Statement filed on January 9, 2002, in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the listed documents are also enclosed.

Applicant requests that the above information be considered by the Examiner and that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such information has been considered.

No fee is believed to be due. Nevertheless, the Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be deemed necessary for filing this paper.

Applicant's undersigned attorney may be reached in our Washington D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Steven E. Warner", is written over a horizontal line.

Attorney for Applicant
Steven E. Warner
Registration No. 33,326

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SEW/eab

